

承湘科技股份有限公司

Customize Metrology Tool

Fulfill all your needs with limited budget

- Filmchek: Film Thickness, Wafer Thickness, TSV
- White Light Interferometers: Step High, 3D Profile, Roughness
- Opti Profiler: Wafer Warpage, Stress, Surface Protrusion Defect
- Overlay: Pattern Shift, Critical Dimension
- ADI/AEI: Macro (Front/Back side), Micro inspection, Surface scan















